U.S. PTO 12/458149 07/01/2009

Form PTO-1595 (Rev. 03-09) U.S. DEPARTMENT OF COMMERCE 07-13-2009 OMB No. 0651-0027 (exp. 03/31 United States Patent and Trademark Office SHEET To the Director of the U.S. 103567074 ched documents or the new address(es) below. 1. Name of conveying party(ies): Name and address of receiving party(ies) Shigeru Yamada OKI SEMICONDUCTOR CO., LTD. Internal Address: Additional name(s) of conveying party(ies) attached? x No Street Address: 3. Nature of conveyance/Execution Date(s): 550-1 Higashiasakawa-cho Hachiouji-shi Execution Date(s): June 13, 2009 x Assignment Merger Change of Name Security Agreement Joint Research Agreement Government Interest Assignment State: Executive Order 9424, Confirmatory License **JAPAN** Country: 193-8550 Additional name(s) & address(es) Yes X No attached? 4. Application or patent number(s): x This document is being filed together with a new application. A. Patent Application No.(s) B. Patent No.(s) JOINED WAFER, FABRICATION METHOD THEREOF, AND FABRICATION METHOD OF SEMICONDUCTOR **DEVICES** Additional numbers attached? X No 5. Name and address to whom correspondence 6. Total number of applications and concerning document should be mailed: patents involved: Steven M. Rabin RABIN & BERDO, PC 7. Total fee (37 CFR 1.21(h) & 3.41) 40.00 Internal Address: Atty. Dkt.: FUJI-219 Street Address: 1101 14th St., NW Authorized to be charged to deposit account Suite 500 None required (government interest not affecting title) City: Washington 8. Payment Information DC 20005 State: Zip: (202) 371-8976 Phone Number: (202) 408-0924 Fax Number: **Deposit Account Number Authorized User Name** firm@rabinberdo.com Email Address: 9. Signature: July 1, 2009 Signature Steven M. Rabin - 29,102 Total number of pages including cover Name of Person Signing sheet, attachments, and documents:

07/02/2009 SZEWDIE1 00008847 12458149 04 FC:8021 40.00 0P

PATENT REEL: 022945 FRAME: 0697

	Attorney Reference
ASSIGNI	MENT OF APPLICATION FOR UNITED STATES LETTERS PATENT
WHEREAS	Shigeru YAMADA
hereinafter referred to co	ollectively as the assignor, has invented a certain improvement
relating to JOINE	WAFER, FABRICATION METHOD: THEREOF, AND FABRICATION METHOD OF
	ONDUCTOR DEVICES
[×] the inventor(s) de	claration for said application being executed concurrently with the execution of this
	tion to be filed in the United States Patent and Trademark Office;
[] said application hav	ing been filed in the United States Patent and Trademark Office on,
	authorization being hereby given to the practitioners associated with the
Customer Number	23995, to insert here in parentheses (Application Serial
No.) the application serial number of said application when known; ing been filed under the Patent Cooperation Treaty on the United States of America being designated.
Social No.)	the United States of America being decignated
Senai No.	the United States of America being designated.
AND WHEREAS	OKI SEMICONDUCTOR CO., LTD.
	of 550-1 Higashiasakawa-cho Hachiouji-shi, Tokyo 193-8550, Japan
	as the assignee, is desirous of acquiring the entire right, title and interest in and to
	ng any and all divisions and continuations thereof, and in and to said invention and
	vhich may be granted therefor, including any and all renewals, reissues and
prolongations thereof;	
NOW THIS WITNE	ESSETH, that for and in consideration of One Dollar (\$1.00), and other good and
	paid by said assignee to said assignor, the receipt of which is hereby acknowledged,
	ssigns, sells and transfers to said assignee, and said assignee's successors and clusive right, title and interest in and to said application, including any and all divisions
	of, and in and to said invention and any and all patents which may be granted therefor
	enewals, reissues and prolongations thereof; sald assignee, and said assignee's
	, to have, hold, exercise and enjoy the said application, including any and all divisions
	of, and the said invention and any and all patents which may be granted therefor,
including any and all rer	newals, reissues and prolongations thereof, with all the rights, powers, privileges and
advantages in anywise	arising from or appertaining thereto, for and during the term or terms of any and all
such patents when gran	nted, including any and all renewals, reissues and prolongations thereof, for the use
	ignee, and said assignee's successors and assigns, in as ample and beneficial a
	gnor might or could have held and enjoyed the same, if this assignment had not been
made.	
	or hereby agrees to perform, upon the request of said assignee, or said assignee's
	any and all acts relating to the obtaining or to the asserting of said patents, including issues and prolongations thereof.
	or authorizes and requests the Commissioner of Patents and Trademarks to issue
Letters Patent on said a	pplication, and on any and all divisions and continuations thereof,
to said assignee, and sa	id assignee's successors and assigns, in accordance herewith.
AND Assignors	hereby grant the following individuals the power to insert on this Assignment any
further identification wh	ich may be necessary or desirable in order to comply with the rules of the United
States Patent and Trade	emark Office for recordation of this document:
	Rabin & Berdo, PC
AH	A
All practitioners at Custo	
invention was made.	acknowledge an obligation of assignment of this invention to Assignee at the time the
mvenuum was maue.	
	7
EXECU	TED, Jupe 13, 2009
LALOO	

ASSIGNOR:

Rabin & Berdo, PC

RECORDED: 07/01/2009

WITNESS:

PATENT REEL: 022945 FRAME: 0698